

Docket No.: 1592-0168PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Naoharu NAKAISO

Application No.: 10/549,933

Confirmation No.: 7899

Filed: September 11, 2006

Art Unit: 1792

For: SUBSTRATE PROCESSING
APPARATUS AND SEMICONDUCTOR
DEVICE PRODUCING METHOD

Examiner: R. N. Kackar

Amendment After Final Action Under 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Sir:

/RK/

INTRODUCTORY COMMENTS

In response to the Office Action dated March 18, 2008, finally rejecting claims 1-4 and 8-20, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page of this paper.

Remarks/Arguments begin on page 7 of this paper.